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Serial No. 10/052,234
Attorney Docket No. 11948.3

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application: Duc Chau et al.	Confirmation No.: 9589
Serial No.: 10/052,234	Group Art Unit: 2823
Filed: January 16, 2002	Examiner: J. Garcia
For: SELF-ALIGNED TRENCH MOSFETS AND METHODS FOR MAKING THE SAME	

CERTIFICATE OF DEPOSIT UNDER 37 C.F.R. § 1.8

I hereby certify that this correspondence and the documents listed below are being deposited with the United States Postal Service as First Class Mail, postage prepaid, in an envelope addressed to: Mail Stop: DD, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 1, day of March 2005.

Kenneth E. Horton
Attorney for Applicant
Registration No. 39,481

Transmitted: Information Disclosure Statement
Form PTO-1449 Listing of All References
Legible Copies of All Foreign Patents and Other Documents
Postcard

KEH:jrr



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SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT
UNDER 37 C.F.R. § 1.97

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P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to a request by Examiner Garcia, only copies of the Foreign Patents and Other Documents are enclosed for entry with the Supplemental Information Disclosure Statement previously faxed on February 15, 2005.

DATED this 1 day of March 2005.

Respectfully submitted,

Kenneth E. Horton
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INFORMATION DISCLOSURE CITATIONS MADE BY APPLICANT

Co-Pending Applications

<u>Examiner Initial*</u>	<u>Application Number</u>	<u>Filing Date</u>
_____ A1.	08/970,221	11/14/97
_____ A2.	09/222,258	12/28/98
_____ A3.	09/267,921	02/26/99
_____ A4.	09/286,168	04/05/99
_____ A5.	09/343,330	06/30/99
_____ A6.	09/405,620	09/24/99
_____ A7.	09/448,884	11/24/99
_____ A8.	09/468,269	12/20/99
_____ A9.	09/640,496	08/16/00
_____ A10.	09/774,780	01/30/01
_____ A11.	09/782,343	02/12/01

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U.S. Patent Application Publication Documents

<u>Examiner Initial*</u>	<u>Document Number</u>	<u>Publ. Date</u>	<u>Name</u>	<u>Class</u>	<u>Sub Class</u>	<u>Filing Date</u>
_____ A12.	2001/0028083	10/11/01	Onishi et al.	257	328	02/09/01

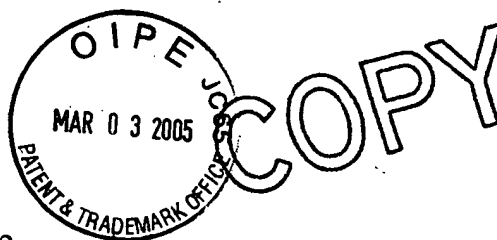
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_____ A13.	2001/0032998	10/25/01	Iwamoto et al.	257	330	03/19/01
_____ A14.	2001/0041400	11/15/01	Ren et al.	438	200	05/10/01
_____ A15.	2001/0050394	12/13/01	Onishi et al.	257	343	04/27/01
_____ A16.	2002/0009832	01/24/02	Blanchard	438	142	01/19/01
_____ A17.	2002/0014658	02/07/02	Blanchard	257	330	05/04/01
_____ A18.	2002/0066924	06/06/02	Blanchard	257	328	10/29/01

U.S. Patent Documents

<u>Examiner Initial*</u>	<u>Document Number</u>	<u>Issue Date</u>	<u>Name</u>	<u>Class</u>	<u>Sub Class</u>	<u>Filing Date</u>
_____ A19.	4,070,690	01/24/78	Wickstrom	357	68	08/17/76
_____ A20.	4,084,311	04/18/78	Yasuoka et al.	29	571	10/15/76
_____ A21.	4,132,998	01/02/79	Dingwall	357	23	08/29/77
_____ A22.	4,138,649	02/06/79	Schaffer	330	9	03/25/77
_____ A23.	4,145,703	03/20/79	Blanchard et al.	357	55	04/15/77
_____ A24.	4,221,044	09/09/80	Godejahn, Jr. et al.	29	571	06/06/78
_____ A25.	4,221,045	09/09/80	Godejahn, Jr.	29	571	06/06/78
_____ A26.	4,264,376	04/28/81	Yatsuda et al.	148	1.5	08/15/79
_____ A27.	4,277,881	07/14/81	Godejahn, Jr.	29	571	05/26/78

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_____ A28.	4,324,038	04/13/82	Chang et al.	29	571	11/24/80
_____ A29.	4,326,332	04/27/82	Kenney	29	571	07/28/80
_____ A30.	4,329,705	05/11/82	Baker	357	43	05/21/79
_____ A31.	4,344,081	08/10/82	Pao et al.	357	43	04/14/80
_____ A32.	4,345,265	08/17/82	Blanchard	357	23	04/14/80
_____ A33.	4,382,827	05/10/83	Romano-Moran et al.	148	1.5	04/27/81
_____ A34.	4,398,339	08/16/83	Blanchard et al.	29	571	09/09/81
_____ A35.	4,419,809	12/13/83	Riseman et al.	29	571	12/30/81
_____ A36.	4,424,621	01/10/84	Abbas et al.	29	571	12/30/81
_____ A37.	4,441,247	04/10/84	Gargini et al.	29	571	06/29/81
_____ A38.	4,452,354	06/05/84	Tabachnick	206	5	01/13/83
_____ A39.	4,455,737	06/26/84	Godejahn, Jr.	29	571	03/11/81
_____ A40.	4,466,172	08/21/84	Batra	29	571	07/27/81
_____ A41.	4,500,898	02/19/85	Cline	357	23	07/06/82
_____ A42.	4,503,449	03/05/85	David et al.	357	23.4	09/10/82
_____ A43.	4,503,598	03/12/85	Vora et al.	29	571	05/20/82
_____ A44.	4,503,601	03/12/85	Chiao	29	571	04/18/83
_____ A45.	4,541,001	09/10/85	Schutten et al.	357	23.4	09/23/82

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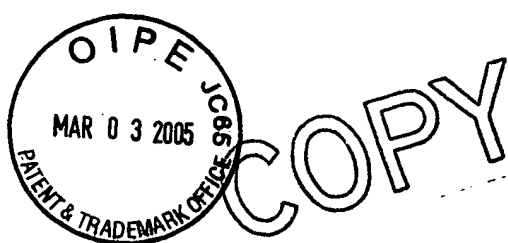
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_____ A46.	4,560,975	12/24/85	Jarva	340	347	03/22/82
_____ A47.	4,568,958	02/04/86	Baliga	357	23.4	01/03/84
_____ A48.	4,577,391	03/25/86	Hsia et al.	29	571	07/27/84
_____ A49.	4,579,621	04/01/86	Hine	156	612	06/25/84
_____ A50.	4,590,458	05/20/86	Evans et al.	340	347	03/04/85
_____ A51.	4,593,453	06/10/86	Tam et al.	29	571	06/18/84
_____ A52.	4,599,789	07/15/86	Gasner	29	571	06/15/84
_____ A53.	4,607,270	08/19/86	Iesaka	357	15	06/08/84
_____ A54.	4,638,344	01/20/87	Cardwell, Jr.	357	22	04/15/82
_____ A55.	4,639,762	01/27/87	Neilson et al.	357	23.8	04/30/84
_____ A56.	4,673,962	06/16/87	Chatterjee et al.	357	23.6	03/21/85
_____ A57.	4,682,405	07/28/87	Blanchard et al.	29	571	07/22/85
_____ A58.	4,683,643	08/04/87	Nakajima et al.	437	203	07/16/85
_____ A59.	4,698,653	10/06/87	Cardwell, Jr.	357	22	10/09/79
_____ A60.	4,701,423	10/20/87	Szluk	437	57	12/20/85
_____ A61.	4,716,126	12/29/87	Cogan	437	24	06/05/86
_____ A62.	4,745,079	05/17/88	Pfiester	437	029	03/30/87
_____ A63.	4,746,630	05/24/88	Hui et al.	437	235	09/17/86

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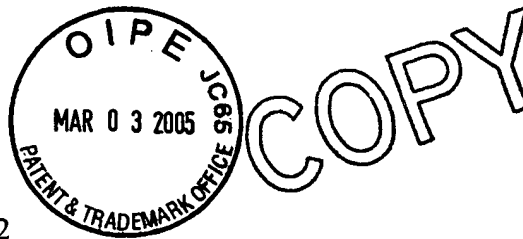
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_____ A64.	4,752,813	06/21/88	Bhatia et al.	357	15	08/08/86
_____ A65.	4,754,310	06/28/88	Coe	357	13	12/04/84
_____ A66.	4,760,033	07/26/88	Mueller	438	231	03/04/87
_____ A67.	4,767,722	08/30/88	Blanchard	437	41	03/24/86
_____ A68.	4,774,556	09/27/88	Fujii et al.	357	23.5	07/21/86
_____ A69.	4,808,543	02/28/89	Parrillo et al.	437	38	05/07/86
_____ A70.	4,811,065	03/07/89	Cogan	357	23.4	06/11/87
_____ A71.	4,824,793	04/25/89	Richardson et al.	437	47	11/12/87
_____ A72.	4,845,537	07/04/89	Nishimura et al.	357	23.4	12/01/87
_____ A73.	4,853,345	08/01/89	Himelick	437	41	08/22/88
_____ A74.	4,860,072	08/22/89	Zommer	357	23.8	03/10/88
_____ A75.	4,881,105	11/14/89	Davari et al.	357	23.4	06/13/88
_____ A76.	4,893,160	01/09/90	Blanchard	357	23.4	11/13/87
_____ A77.	4,903,189	02/20/90	Ngo et al.	363	127	04/27/88
_____ A78.	4,912,061	03/27/90	Nasr	437	44	04/04/88
_____ A79.	4,914,058	04/03/90	Blanchard	437	203	12/29/87
_____ A80.	4,941,026	07/10/90	Temple	357	23.4	08/26/88
_____ A81.	4,946,799	08/07/90	Blake et al.	437	41	11/09/89

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_____ A82.	4,956,308	09/11/90	Griffin et al.	437	41	01/20/87
_____ A83.	4,961,100	10/02/90	Baliga et al.	357	39	06/20/88
_____ A84.	4,967,245	10/30/90	Cogan et al.	357	23.4	03/14/88
_____ A85.	4,983,535	01/08/91	Blanchard	437	40	12/28/88
_____ A86.	4,990,463	02/05/91	Mori	437	52	06/29/89
_____ A87.	4,992,390	02/12/91	Chang	437	42	07/06/89
_____ A88.	5,016,068	05/14/91	Mori	357	23.5	12/08/89
_____ A89.	5,017,504	05/21/91	Nishimura et al.	437	40	04/21/89
_____ A90.	5,021,846	06/04/91	Ueno	357	23.4	02/06/90
_____ A91.	5,034,785	07/23/91	Blanchard	257	330	08/24/88
_____ A92.	5,045,900	09/03/91	Tamagawa	357	23.4	01/22/91
_____ A93.	5,065,273	11/12/91	Rajeevakumar	361	313	12/04/90
_____ A94.	5,071,782	12/10/91	Mori	437	48	06/28/90
_____ A95.	5,072,266	12/10/91	Bulucea et al.	357	23.4	12/27/88
_____ A96.	5,111,253	05/05/92	Korman et al.	357	15	08/28/90
_____ A97.	5,124,764	06/23/92	Mori	357	23.4	01/03/91
_____ A98.	5,134,448	07/28/92	Johnsen et al.	357	23.4	01/22/91
_____ A99.	5,156,989	10/20/92	Williams et al.	437	41	11/08/88

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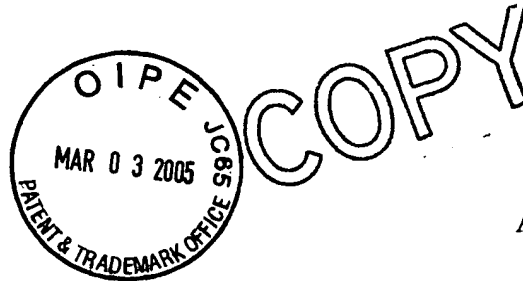
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_____ A100.	5,160,491	11/03/92	Mori	437	40	02/19/91
_____ A101.	5,164,325	11/17/92	Cogan et atl.	437	29	10/08/87
_____ A102.	5,164,327	11/17/92	Maruyama	437	40	10/08/91
_____ A103.	5,168,331	12/01/92	Yilmaz	257	331	01/31/91
_____ A104.	5,169,796	12/08/92	Murray et al.	437	41	09/19/91
_____ A105.	5,177,572	01/05/93	Murakami	257	260	04/05/91
_____ A106.	5,188,973	02/23/93	Omura et al.	437	40	04/30/92
_____ A107.	5,208,657	05/04/93	Chatterjee et al.	257	302	07/22/91
_____ A108.	5,216,275	06/01/93	Chen	257	493	09/17/91
_____ A109.	5,219,793	06/15/93	Cooper et al.	437	195	06/03/91
_____ A110.	5,242,845	09/07/93	Baba et al.	437	40	04/10/92
_____ A111.	5,250,450	10/05/93	Lee et al.	437	40	02/12/92
_____ A112.	5,273,922	12/28/93	Tsoi	437	41	09/11/92
_____ A113.	5,275,961	01/04/94	Smayling et al.	437	41	07/16/92
_____ A114.	5,275,965	01/04/94	Manning	437	67	11/25/92
_____ A115.	5,281,548	01/25/94	Prall	437	43	07/28/92
_____ A116.	5,294,824	03/15/94	Okada	257	409	07/31/92
_____ A117.	5,298,442	03/29/94	Bulucea et al.	437	40	09/18/91

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_____ A118.	5,298,780	03/29/94	Harada	257	330	11/24/92
_____ A119.	5,298,781	03/29/94	Cogan et al.	257	333	07/08/92
_____ A120.	5,300,447	04/05/94	Anderson	437	41	09/29/92
_____ A121.	5,300,452	04/05/94	Chang et al.	437	126	10/27/92
_____ A122.	5,304,831	04/19/94	Yilmaz et al.	257	341	05/12/92
_____ A123.	5,316,959	05/31/94	Kwan et al.	437	40	08/12/92
_____ A124.	5,326,711	07/05/94	Malhi	437	33	01/04/93
_____ A125.	5,341,011	08/23/94	Hshieh et al.	257	330	03/15/93
_____ A126.	5,346,834	09/13/94	Hisamoto et al.	437	41	03/03/92
_____ A127.	5,350,937	09/27/94	Yamazaki et al.	257	316	10/07/92
_____ A128.	5,365,102	11/15/94	Mehrotra et al.	257	475	07/06/93
_____ A129.	5,366,914	11/22/94	Takahashi et al.	437	41	01/29/93
_____ A130.	5,389,570	02/14/95	Shiozawa	437	101	08/18/92
_____ A131.	5,399,513	03/21/95	Liou et al.	437	34	11/17/92
_____ A132.	5,405,794	04/11/95	Kim	437	41	06/14/94
_____ A133.	5,410,170	04/25/95	Bulucea et al.	257	332	04/14/93
_____ A134.	5,420,452	05/30/95	Tran et al.	257	428	10/18/93
_____ A135.	5,424,231	06/13/95	Yang	437	40	08/09/94

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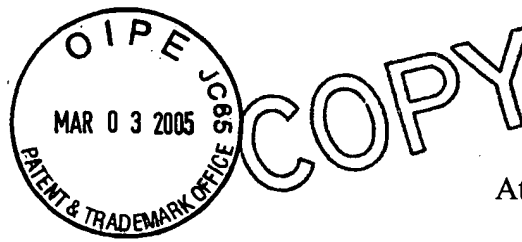
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_____ A136.	5,429,977	07/04/95	Lu et al.	437	52	03/11/94
_____ A137.	5,430,324	07/04/95	Bencuya	257	495	07/23/92
_____ A138.	5,432,105	07/11/95	Chien	437	34	09/19/94
_____ A139.	5,438,007	08/01/95	Vinal et al.	437	41	09/28/93
_____ A140.	5,438,215	08/01/95	Tihanyi	257	401	03/25/94
_____ A141.	5,455,190	10/03/95	Hsu	437	40	12/07/94
_____ A142.	5,468,982	11/21/95	Hshieh et al.	257	331	06/03/94
_____ A143.	5,472,887	12/05/95	Hutter et al.	437	34	11/09/93
_____ A144.	5,473,176	12/05/95	Kakumoto	257	192	08/31/94
_____ A145.	5,473,180	12/05/95	Ludikhuize	257	336	07/11/94
_____ A146.	5,474,943	12/12/95	Hshieh et al.	437	40	08/11/94
_____ A147.	5,488,010	01/30/96	Wong	437	53	05/10/94
_____ A148.	5,508,534	04/16/96	Nakamura et al.	257	135	02/07/95
_____ A149.	5,514,608	05/07/96	Williams et al.	437	44	10/04/94
_____ A150.	5,532,179	07/02/96	Chang et al.	437	40	05/23/95
_____ A151.	5,541,425	07/30/96	Nishihara	257	139	12/19/94
_____ A152.	5,547,895	08/20/96	Yang	437	57	08/31/94
_____ A153.	5,554,552	09/10/96	Chi	437	43	04/03/95

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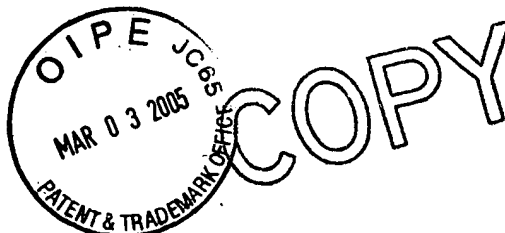
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_____	A154.	5,554,862	09/10/96	Omura et al.	257	137	01/19/94
_____	A155.	5,558,313	09/24/96	Hshieh et al.	257	342	02/10/95
_____	A156.	5,567,634	10/22/96	Hebert et al.	437	41	05/01/95
_____	A157.	5,576,245	11/19/96	Cogan et al.	437	203	11/18/92
_____	A158.	5,578,851	11/26/96	Hshieh et al.	257	330	03/29/96
_____	A159.	5,581,100	12/03/96	Ajit	257	331	08/30/94
_____	A160.	5,583,065	12/10/96	Miwa	437	41	12/06/95
_____	A161.	5,592,005	01/07/97	Floyd et al.	257	331	03/31/95
_____	A162.	5,593,909	01/14/97	Han et al.	437	41	06/06/95
_____	A163.	5,595,927	01/21/97	Chen et al.	437	52	03/17/95
_____	A164.	5,597,765	01/28/97	Yilmaz et al.	437	203	04/17/95
_____	A165.	5,602,046	02/11/97	Calafut et al.	437	41	04/12/96
_____	A166.	5,605,852	02/25/97	Bencuya	437	40	05/18/95
_____	A167.	5,614,751	03/25/97	Yilmaz et al.	257	394	04/15/96
_____	A168.	5,623,152	04/22/97	Majumdar et al.	257	330	11/21/95
_____	A169.	5,629,543	05/13/97	Hshieh et al.	257	330	08/21/95
_____	A170.	5,639,676	06/17/97	Hshieh et al.	437	40	02/16/96
_____	A171.	5,648,670	07/15/97	Blanchard	257	329	06/07/95

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_____ A172.	5,656,843	08/12/97	Goodyear et al.	257	329	06/13/96
_____ A173.	5,661,322	08/26/97	Williams et al.	257	331	06/02/95
_____ A174.	5,665,619	09/09/97	Kwan et al.	438	270	05/13/96
_____ A175.	5,665,996	09/09/97	Williams et al.	257	401	12/30/94
_____ A176.	5,674,766	10/07/97	Darwish et al.	437	40	04/26/95
_____ A177.	5,684,319	11/04/97	Hebert	257	336	08/24/95
_____ A178.	5,684,320	11/04/97	Kawashima	257	351	07/03/95
_____ A179.	5,688,725	11/18/97	Darwish et al.	438	270	06/06/95
_____ A180.	5,689,128	11/18/97	Hshieh et al.	257	331	08/21/95
_____ A181.	5,693,569	12/02/97	Ueno	437	203	12/18/96
_____ A182.	5,701,026	12/23/97	Fujishima et al.	257	510	10/25/95
_____ A183.	5,705,409	01/06/98	Witek	437	35	09/28/95
_____ A184.	5,710,072	01/20/98	Krautschneider et al.	438	197	05/02/95
_____ A185.	5,717,237	02/10/98	Chi	257	315	06/17/96
_____ A186.	5,719,084	02/17/98	Mallon et al.	438	783	11/29/95
_____ A187.	5,719,409	02/17/98	Singh et al.	257	77	06/06/96
_____ A188.	5,721,148	02/24/98	Nishimura	437	40	12/03/96
_____ A189.	5,729,037	03/17/98	Hshieh et al.	257	329	04/26/96

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_____ A190.	5,741,396	04/21/98	Loewenstein	156	643.1	04/29/94
_____ A191.	5,767,004	06/16/98	Balasubramanian et al.	438	592	04/22/96
_____ A192.	5,767,550	06/16/98	Calafut et al.	257	355	10/16/96
_____ A193.	5,770,878	06/23/98	Beasom	257	330	04/10/96
_____ A194.	5,780,343	07/14/98	Bashir	438	269	12/20/95
_____ A195.	5,783,491	07/21/98	Nakamura et al.	438	702	02/02/95
_____ A196.	5,783,493	07/21/98	Yeh et al.	438	718	01/27/97
_____ A197.	5,795,792	08/18/98	Nishihara	437	6	05/10/96
_____ A198.	5,801,408	09/01/98	Takahashi	257	212	02/13/96
_____ A199.	5,801,417	09/01/98	Tsang et al.	257	333	08/13/93
_____ A200.	5,808,340	09/15/98	Wollesen et al.	257	330	09/18/96
_____ A201.	5,814,858	09/29/98	Williams	257	328	03/15/96
_____ A202.	5,818,084	10/06/98	Williams et al.	257	329	05/15/96
_____ A203.	5,869,874	02/09/99	Manning	257	382	01/02/97
_____ A204.	5,879,971	03/09/99	Witek	438	238	09/28/95
_____ A205.	5,879,994	03/09/99	Kwan et al.	438	268	04/15/97
_____ A206.	5,894,157	04/13/99	Han et al.	257	407	06/27/94
_____ A207.	5,895,951	04/20/99	So et al.	257	330	04/05/96

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_____ A208.	5,895,952	04/20/99	Darwish et al.	257	330	08/21/96
_____ A209.	5,897,374	04/27/99	Lin	438	666	06/04/97
_____ A210.	5,915,180	06/22/99	Hara et al.	438	270	04/05/95
_____ A211.	5,929,690	07/27/99	Williams	327	374	09/25/97
_____ A212.	5,943,581	08/24/99	Lu et al.	438	386	11/05/97
_____ A213.	5,945,724	08/31/99	Parekh et al.	257	510	04/09/98
_____ A214.	5,959,324	09/28/99	Kohyama	257	301	07/11/97
_____ A215.	5,972,741	10/26/99	Kubo et al.	438	138	10/28/97
_____ A216.	5,973,360	10/26/99	Tihanyi	257	330	09/21/98
_____ A217.	5,977,591	11/02/99	Fratin et al.	257	344	03/18/97
_____ A218.	5,998,833	12/07/99	Baliga	257	329	10/26/98
_____ A219.	5,998,836	12/07/99	Williams	257	341	04/30/97
_____ A220.	5,998,837	12/07/99	Williams	257	341	08/28/97
_____ A221.	6,001,704	12/14/99	Cheng et al.	438	410	06/04/98
_____ A222.	6,005,271	12/21/99	Hshieh	257	341	11/05/97
_____ A223.	6,008,097	12/28/99	Yoon et al.	438	303	12/11/97
_____ A224.	6,008,520	12/28/99	Darwish et al.	257	330	07/16/97
_____ A225.	6,015,727	01/18/00	Wanlass	438	218	06/08/98

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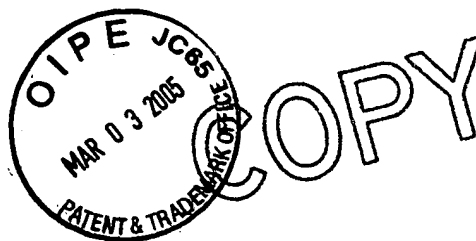
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_____ A226.	6,020,250	02/01/00	Kenney	438	422	04/01/98
_____ A227.	6,037,202	03/14/00	Witek	438	212	08/18/97
_____ A228.	6,037,628	03/14/00	Huang	257	329	06/30/97
_____ A229.	6,037,632	03/14/00	Omura et al.	257	341	11/05/96
_____ A230.	6,040,600	03/21/00	Uenishi et al.	257	330	08/11/97
_____ A231.	6,049,108	04/11/00	Williams et al.	257	341	08/28/97
_____ A232.	6,051,468	04/18/00	Hshieh	438	270	09/15/97
_____ A233.	6,051,488	04/18/00	Lee et al.	438	589	01/14/98
_____ A234.	6,057,558	05/02/00	Yamamoto et al.	257	77	03/04/98
_____ A235.	6,060,745	05/09/00	Tadokoro et al.	257	329	01/06/98
_____ A236.	6,066,878	05/23/00	Neilson	257	342	07/02/98
_____ A237.	6,074,923	06/13/00	Lee	438	305	06/09/98
_____ A238.	6,081,009	06/27/00	Neilson	257	341	11/10/97
_____ A239.	6,084,264	07/04/00	Darwish	257	329	11/25/98
_____ A240.	6,084,268	07/04/00	de Fresart et al.	257	342	11/03/97
_____ A241.	6,087,232	07/11/00	Kim et al.	438	289	08/18/98
_____ A242.	6,091,115	07/18/00	Ohtani et al.	257	369	11/14/97
_____ A243.	6,096,629	08/01/00	Tsai et al.	438	570	11/05/98

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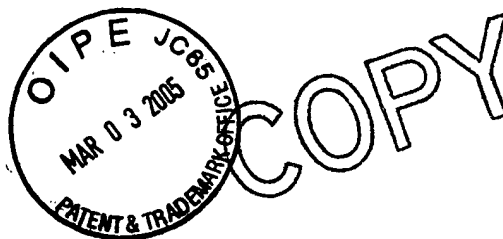
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_____ A244.	6,097,061	08/01/00	Liu et al.	257	330	03/30/98
_____ A245.	6,097,063	08/01/00	Fujihira	257	339	01/21/97
_____ A246.	6,100,132	08/08/00	Sato et al.	438	243	06/29/98
_____ A247.	6,103,578	08/15/00	Uenishi et al.	438	268	04/02/99
_____ A248.	6,107,192	08/22/00	Subrahmanyam et al.	438	637	12/30/97
_____ A249.	6,110,799	08/29/00	Huang	438	430	06/30/97
_____ A250.	6,133,587	10/17/00	Takeuchi et al.	257	77	02/13/98
_____ A251.	6,156,606	12/05/00	Michaelis	438	243	11/17/98
_____ A252.	6,156,611	12/05/00	Lan et al.	438	268	07/20/98
_____ A253.	6,159,823	12/12/00	Song et al.	438	437	09/23/99
_____ A254.	6,163,052	12/19/00	Liu et al.	257	334	12/16/97
_____ A255.	6,168,983	01/02/01	Rumennik et al.	438	188	02/05/99
_____ A256.	6,171,935	01/09/01	Nance et al.	438	489	05/24/99
_____ A257.	6,174,785	01/16/01	Parekh et al.	438	424	06/18/98
_____ A258.	6,184,545	02/06/01	Werner et al.	257	109	09/14/98
_____ A259.	6,184,555	02/06/01	Tihanyi et al.	257	342	12/04/98
_____ A260.	6,188,105	02/13/01	Kocon et al.	257	330	04/01/99
_____ A261.	6,191,447	02/20/01	Baliga	257	330	05/28/99

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_____	A262.	6,198,127	03/06/01	Kocon	257	328	05/19/99
_____	A263.	6,201,279	03/13/01	Pfirsch	257	333	10/22/99
_____	A264.	6,204,097	03/20/01	Shen et al.	438	133	03/01/99
_____	A265.	6,204,533	03/20/01	Williams et al.	257	341	06/02/98
_____	A266.	6,207,994	03/27/01	Rumennik et al.	257	342	02/05/99
_____	A267.	6,222,229	04/24/01	Hebert et al.	257	327	06/14/99
_____	A268.	6,225,649	05/01/01	Minato	257	133	01/22/98
_____	A269.	6,228,727	05/08/01	Lim et al.	438	296	09/27/99
_____	A270.	6,239,464	05/29/01	Tsuchitani et al.	257	330	01/07/99
_____	A271.	6,265,269	07/24/01	Chen et al.	438	270	08/06/99
_____	A272.	6,271,100	08/07/01	Ballantine et al.	438	424	02/24/00
_____	A273.	6,271,153	08/07/01	Moore	438	787	06/26/00
_____	A274.	6,271,562	08/07/01	Deboy et al.	257	341	03/01/99
_____	A275.	6,277,706	08/21/01	Ishikawa	438	424	06/08/98
_____	A276.	6,291,298	09/18/01	Williams et al.	438	270	05/25/99
_____	A277.	6,291,856	09/18/01	Miyasaka et al.	257	335	11/10/99
_____	A278.	6,294,818	09/25/01	Fujihiro	257	409	05/30/00
_____	A279.	6,297,534	10/02/01	Kawaguchi et al.	257	341	10/07/99

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_____ A280.	6,307,246	10/23/01	Nitta et al.	257	493	07/23/98
_____ A281.	6,309,920	10/30/01	Laska et al.	438	202	07/20/98
_____ A282.	6,313,482	11/06/01	Baliga	257	77	05/17/99
_____ A283.	6,326,656	12/04/01	Tihanyi	257	288	02/24/00
_____ A284.	6,337,499	01/08/02	Werner	257	329	08/17/98
_____ A285.	6,346,464	02/12/02	Takeda et al.	438	514	06/27/00
_____ A286.	6,346,469	02/12/02	Greer	438	614	01/03/00
_____ A287.	6,351,018	02/26/02	Sapp	257	499	02/26/99
_____ A288.	6,353,252	03/05/02	Yasuhara et al.	257	487	07/28/00
_____ A289.	6,362,112	03/26/02	Hamerski	438	737	11/08/00
_____ A290.	6,362,505	03/26/02	Tihanyi	257	329	07/27/00
_____ A291.	6,365,462	04/02/02	Baliga	438	270	11/29/00
_____ A292.	6,365,930	04/02/02	Schillaci et al.	257	339	06/01/00
_____ A293.	6,368,921	04/09/02	Hijzen et al.	438	270	09/28/00
_____ A294.	6,376,314	04/23/02	Jerred	438	270	11/06/98
_____ A295.	6,384,456	05/07/02	Tihanyi	257	401	03/30/00
_____ A296.	6,387,764	05/14/02	Curtis et al.	438	296	03/31/00
_____ A297.	6,388,287	05/14/02	Deboy et al.	257	341	03/12/01

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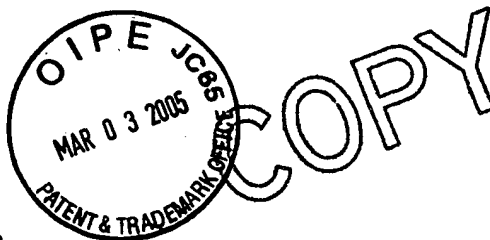
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_____ A298.	6,400,003	06/04/02	Huang	257	653	12/02/99
_____ A299.	6,437,399	08/20/02	Huang	257	329	02/04/00
_____ A300.	6,566,224	05/20/03	Chang et al.	438	424	07/31/97

Foreign Patent Documents

<u>Examiner Initial*</u>	<u>Document Number</u>	<u>Publ. Date</u>	<u>Country or Patent Office</u>	<u>Sub Class</u>	<u>Class</u>	<u>Trans- lation</u>
_____ A301.	CN 1 036 666	10/25/89	China	--	--	Yes
_____ A302.	DE 43 00 806C1	12/23/93	Dutch	--	--	Yes
_____ A303.	EP 0 238 749	09/30/87	EPO	--	--	Yes
_____ A304.	EP 0 550 770	07/14/93	EPO	--	--	Yes
_____ A305.	EP 0 583 028	02/16/94	EPO	--	--	Yes
_____ A306.	EP 0 698 919	02/28/96	EPO	--	--	Yes
_____ A307.	EP 0 720 235	07/03/96	EPO	--	--	Yes
_____ A308.	EP 0 720 236	07/03/96	EPO	--	--	Yes
_____ A309.	EP 0 746 030	12/04/96	EPO	--	--	Yes
_____ A310.	EP 0 747 967	12/11/96	EPO	--	--	Yes
_____ A311.	EP 0 755 076	01/22/97	EPO	--	--	Yes
_____ A312.	EP 0 795 911	09/17/97	EPO	--	--	Yes

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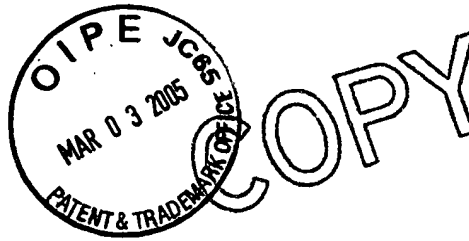
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_____	A313.	EP 0 801 425	10/15/97	EPO	--	--	Yes
_____	A314.	EP 0 975 024	01/26/00	EPO	--	--	Yes
_____	A315.	GB 2 269 050	01/26/94	UK	--	--	Yes
_____	A316.	JP 56 131 960	10/15/81	Japan	--	--	Yes
_____	A317.	JP 57 018 365	01/30/82	Japan	--	--	Yes
_____	A318.	JP 57 153 469	09/22/82	Japan	--	--	Yes
_____	A319.	JP 58 137 254	08/15/83	Japan	--	--	Yes
_____	A320.	JP 58 210 678	12/07/83	Japan	--	--	Yes
_____	A321.	JP 59 080 970	05/10/84	Japan	--	--	Yes
_____	A322.	JP 59 193 064	11/01/84	Japan	--	--	Yes
_____	A323.	JP 60 028 271	02/13/85	Japan	--	--	Yes
_____	A324.	JP 61 102 782	05/21/86	Japan	--	--	Yes
_____	A325.	JP 62 012 167	01/21/87	Japan	--	--	Yes
_____	A326.	JP 62 016 572	01/24/87	Japan	--	--	Yes
_____	A327.	JP 62 023 171	01/31/87	Japan	--	--	Yes
_____	A328.	JP 62 046 569	02/28/87	Japan	--	--	Yes
_____	A329.	JP 62 179 482	08/06/87	Japan	--	--	Yes
_____	A330.	JP 63 114 173	05/19/88	Japan	--	--	Yes

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_____	A331.	JP 63 288 047	11/25/88	Japan	--	--	Yes
_____	A332.	JP 1 94 672	04/13/89	Japan	--	--	Yes
_____	A333.	JP 5 226 661	09/03/93	Japan	--	--	Yes
_____	A334.	JP 5 251 387	09/28/93	Japan	--	--	Yes
_____	A335.	JP 6 163 910	06/10/94	Japan	--	--	Yes
_____	A336.	JP 8 204 194	08/09/96	Japan	--	--	Yes
_____	A337.	JP 8 250 731	09/27/96	Japan	--	--	Yes
_____	A338.	JP 8 316 479	11/29/96	Japan	--	--	Yes
_____	A339.	JP 9 036 362	02/07/97	Japan	--	--	Yes
_____	A340.	JP 9 102 607	04/15/97	Japan	--	--	Yes
_____	A341.	JP 9 270 512	10/14/97	Japan	--	--	Yes
_____	A342.	JP 2000 040 822	02/08/00	Japan	--	--	Yes
_____	A343.	JP 2000 040 872	02/08/00	Japan	--	--	Yes
_____	A344.	JP 2000 156 978	06/06/00	Japan	--	--	Yes
_____	A345.	JP 2000 277 726	10/06/00	Japan	--	--	Yes
_____	A346.	JP 2000 277 728	10/06/00	Japan	--	--	Yes
_____	A347.	JP 2001 015 448	01/19/01	Japan	--	--	Yes
_____	A348.	JP 2001 015 752	01/19/01	Japan	--	--	Yes

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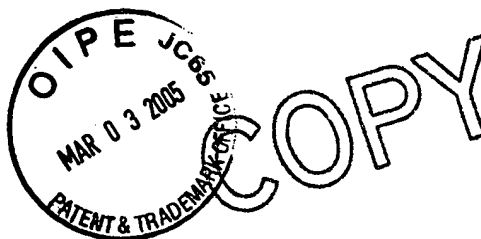
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_____ A349.	JP 2001 102 577	04/13/01	Japan	--	--	Yes
_____ A350.	JP 2001 111 041	04/20/01	Japan	--	--	Yes
_____ A351.	JP 2001 135 819	05/18/01	Japan	--	--	Yes
_____ A352.	JP 2001 144 292	05/25/01	Japan	--	--	Yes
_____ A353.	JP 2001 244 461	09/07/01	Japan	--	--	Yes
_____ A354.	JP 2001 313 391	11/09/01	Japan	--	--	Yes
_____ A355.	WO 93/03502	02/18/93	PCT	--	--	Yes
_____ A356.	WO 95/34094	12/14/95	PCT	--	--	Yes
_____ A357.	WO 97/07547	02/27/97	PCT	--	--	Yes
_____ A358.	WO 97/16853	05/09/97	PCT	--	--	Yes
_____ A359.	WO 00/33386	06/08/00	PCT	--	--	Yes
_____ A360.	WO 00/68997	11/16/00	PCT	--	--	Yes
_____ A361.	WO 00/68998	11/16/00	PCT	--	--	Yes
_____ A362.	WO 01/06550	01/25/01	PCT	--	--	Yes
_____ A363.	WO 01/06557	01/25/01	PCT	--	--	Yes
_____ A364.	WO 01/45155	06/21/01	PCT	--	--	Yes
_____ A365.	WO 01/59847	08/16/01	PCT	--	--	Yes
_____ A366.	WO 01/71815	09/27/01	PCT	--	--	Yes

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_____ A367.	WO 01/95385	12/13/01	PCT	--	--	Yes
_____ A368.	WO 01/95398	06/01/01	PCT	--	--	Yes

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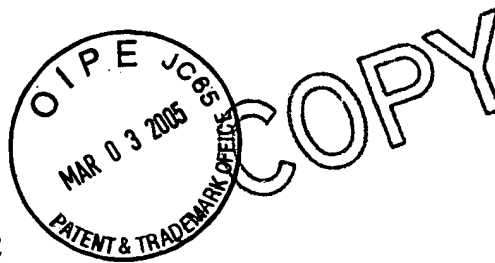
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